THE IDAHO MICROFABRICATION LAB



Boise State University College of Engineering campus, this research, training and teaching facility was established in 1998 and operates as a shared-user facility accessible by industry partners. With a 900 ft² ISO 5 Cleanroom, a 1500 ft² Process Lab and a 900 ft² Metrology and Printed Electronics Lab, the IML is equipped to assist entrepreneurs and technologists with R&D projects involving microelectronics and semiconductor fabrication technologies.

- Additive Manufacturing
- Photolithography
- Dry & Wet Etch Processing
- Physical Vapor Deposition
- Metrology & Characterization
- Self service is available
- Services can be provided
- Accessible by industry professionals
- Competitive user rates
- Workforce development





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